

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

(Case No. 98,162)

In re Application of:

DeGendt, et al.

Serial No.: 09/022,834

Filed: February 13, 1998

For: METHOD FOR REMOVING ORGANIC  
CONTAMINANTS FROM A  
SEMICONDUCTOR SURFACE

Group Art Unit: 1746

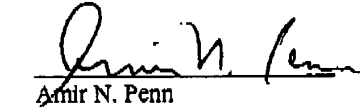
Examiner: Ahmed

**FACSIMILE TRANSMITTAL LETTER**Commissioner for Patents  
Washington, D.C. 20231Attn: Examiner Ahmed  
Fax (703) 872-9055No. of Pages: 9  
Including this Transmittal Letter

Sir:

In regard to the above identified application:

1. We are transmitting herewith the attached:
  - a. Supplemental Response to Office Action Dated November 7, 2001
2. Please charge any additional fees or credit overpayment to Deposit Account No. 13-2490.
3. CERTIFICATE OF TRANSMISSION UNDER 37 CFR § 1.8: The undersigned hereby certifies that this Transmittal Letter and the paper, as described in paragraph 1 hereinabove, are being facsimile transmitted to the Patent and Trademark Office (Fax No. (703) 872-9055) on this 6<sup>th</sup> day of August, 2002.

  
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8/7/02

Commissioner for Patents  
Washington, D.C. 20231

**SUPPLEMENTAL RESPONSE TO OFFICE ACTION**  
**DATED NOVEMBER 7, 2001**

Dear Sir:

Applicants submit the following supplemental response to the Office Action  
mailed November 7, 2001.

**REMARKS**

***Claim Rejections***

In paragraph five of the Office Action, claims 27-28, 30-39, 41-43, 47-49, 51-57 and 60  
were rejected under 35 U.S.C. §103(a) as being unpatentable over Ilardi et al. (U.S. Patent No.  
5,466,389) in view of Kern (Hand Book of Semiconductor wafer cleaning technology) and  
further in view of Sehested et al. (J.Phys.Chem.). In paragraph six of the Office Action, claims

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